

A Wireless, Battery-Free Temperature Sensor Utilizing the Morphotropic Phase Boundary of $\text{Hf}_x\text{Zr}_{1-x}\text{O}_2$ Thin Film

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Table S1. Comparative analysis of existing wireless temperature sensors.

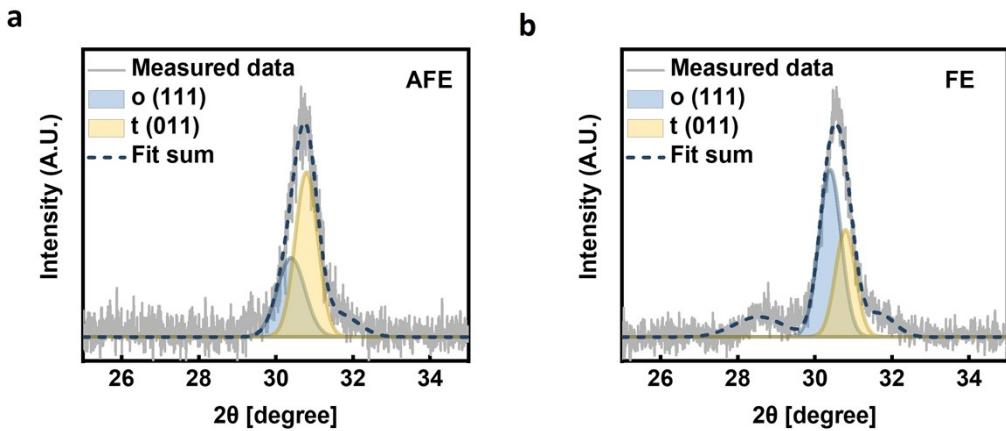


Figure S1. GIXRD of antiferroelectric and ferroelectric HZO films.

Figure S1a illustrates an antiferroelectric sample, in which the o-phase content is substantially lower than that of the t-phase. Conversely, Figure S1b depicts a ferroelectric sample, where the o-phase is predominant and surpasses the t-phase content.

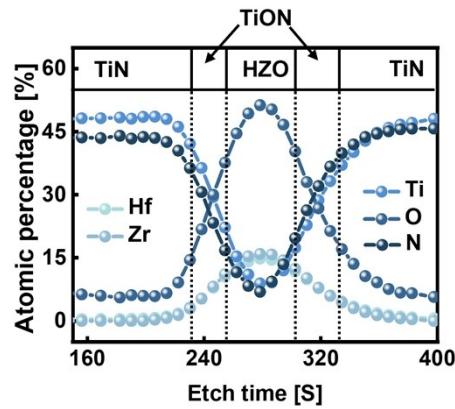


Figure S2. X-ray diffraction pattern of HZO films.

As etch time progresses, the sample exhibits a transition from TiN to TiON and subsequently to HZO. Furthermore, a relatively deep atomic diffusion at the bottom interface is observed, which is attributed to the unavoidable plasma-induced damage during the HZO deposition process.

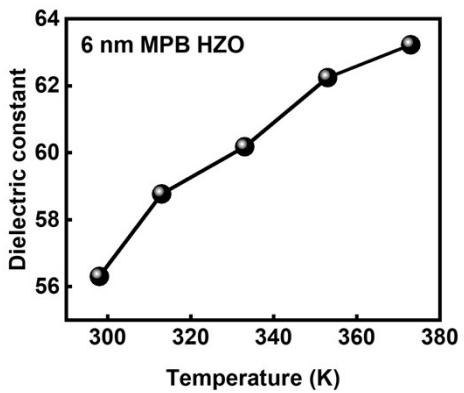


Figure S3. Dielectric constant as a function of the temperature.

The dielectric constant at E_C (0 V) increases from 56.3 at 297 K to 63.2 at 373 K.

Material	Integration	Temperature range	Wireless distance	Battery-Free	Reference #
Polyethylene Glycol	No	305 K- 315 K	16 mm	Yes	1
CNT/SnO ₂	No	291 K- 298 K		No	2
PEDOT: PSS	No	303 K- 323 K		No	3
Plasmonic material TiN	Yes	293 K-373 K	No	No	4
BaTiO ₃	No	303 K- 323 K		Yes	5
PDMS-CF	No	293 K-373 K		Yes	6
PEDOT: PSS	No	293 K-378 K		Yes	7
Hf _x Zr _{1-x} O ₂	Yes	293 K-373 K	10 mm	Yes	This work

Table S1. Comparative analysis of existing wireless temperature sensors.

This table presents a comparison of key parameters of state-of-the-art temperature sensors developed over the past five years ¹⁻⁷.

Reference

1. D. Lu, Y. Yan, R. Avila, I. Kandela, I. Stepien, M. H. Seo, W. Bai, Q. Yang, C. Li and C. R. Haney, *Advanced Healthcare Materials*, 2020, **9**, 2000942.
2. Y. Lu, Y. Fujita, S. Honda, S. H. Yang, Y. Xuan, K. Xu, T. Arie, S. Akita and K. Takei, *Advanced Healthcare Materials*, 2021, **10**, 2100103.
3. W. Fan, T. Liu, F. Wu, S. Wang, S. Ge, Y. Li, J. Liu, H. Ye, R. Lei and C. Wang, *ACS nano*, 2023, **17**, 21073-21082.
4. R. Rahad, M. M. Sobhani, M. J. H. Emon, S. M. T.-S. Afrid, M. K. Mahadi, A. S. Mohsin, M. O. Faruque and R. H. Sagor, *Optics Communications*, 2024, **569**, 130749.
5. G. Clementi, I. Neri, F. Cottone, A. Di Michele, M. Mattarelli, L. Sforza, S. Chiappalupi, G. Sorci, A. Michelucci and L. Catacuzzeno, *Nano Energy*, 2024, **121**, 109211.
6. B. King, N. Bruce and M. Wagih, *Advanced Science*, 2025, 2412066.
7. Y. Wang, Z. Chen, T. Huang, J. Ren, J. Zhang, Z. Yuan and G. Shen, *Nano Energy*, 2025, **133**, 110492.